



#24 PB 3/21/03  
Docket No.1539.1002RE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of :  
Tomowaki TAKAHASHI :  
Serial No.: 09/659,375 : Group Art Unit: 2872  
Confirmation No.: 5004  
Filed: September 8, 2000 : Examiner: L. Fineman  
For: CATADIOPTRIC PROJECTION SYSTEMS

LETTER TO THE EXAMINER REQUESTING STATUS

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Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Further to a review of the Patent Application Information Retrieval (PAIR) system, we note that the instant application is in condition for allowance consistent with the conversation with the Examiner on January 21, 2003, and that the PAIR system does not reflect a Supplemental Amendment we filed on January 21, 2003. However, we have not yet received a Notice of Allowability. Applicant respectfully requests the status of the above-identified patent application, including an indication as to when the Notice of Allowability can be expected.

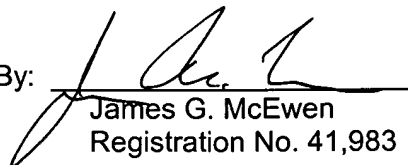
Further, A copy of the Supplemental Amendment is enclosed.

If the Examiner has any remaining issues to be addressed, it is believed that prosecution can be expedited by the Examiner contacting the undersigned attorney for a telephone interview to discuss resolution of such issues.

Respectfully submitted,

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Date: March 19, 2003